

18W/1756

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI

Group Art Unit: 1756

Application No.: 10/523,470

Filed: March 10, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK BLANK, METHOD FOR
MANUFACTURING TRANSFER MASK, SPUTTERING TARGET FOR
MANUFACTURING MASK BLANK

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to Reference 1 of the PTO Form 1449 filed concurrently with the Information Disclosure Statement on November 14. It is respectfully requested that the reference be expressly considered in view of the attached English-language translation of a Korean Office Action, which provides a further concise explanation of potential relevance of the reference. JP 2001-303243, also cited in the Office Action, was disclosed to the Patent and Trademark Office in and Information Disclosure Statement filed on March 10, 2005.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

David R. Kemeny
Registration No. 57,241

JAO:DRK/aha

Date: December 29, 2006

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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